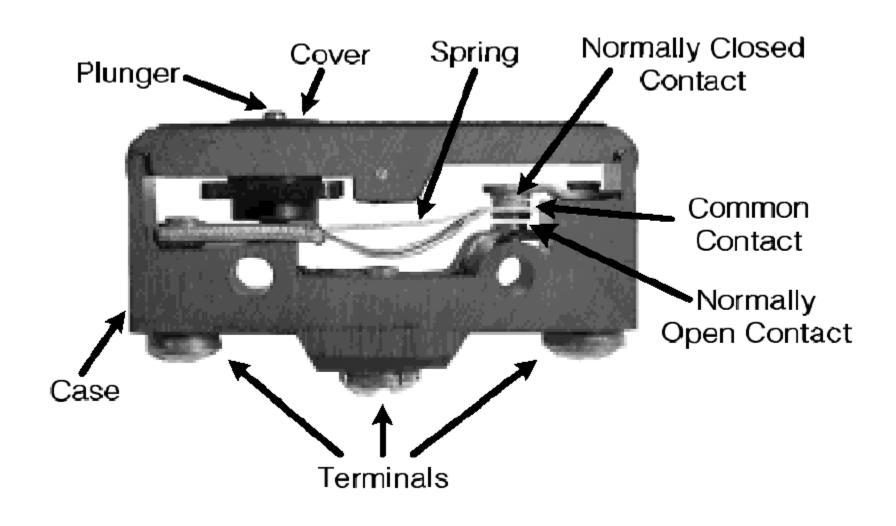
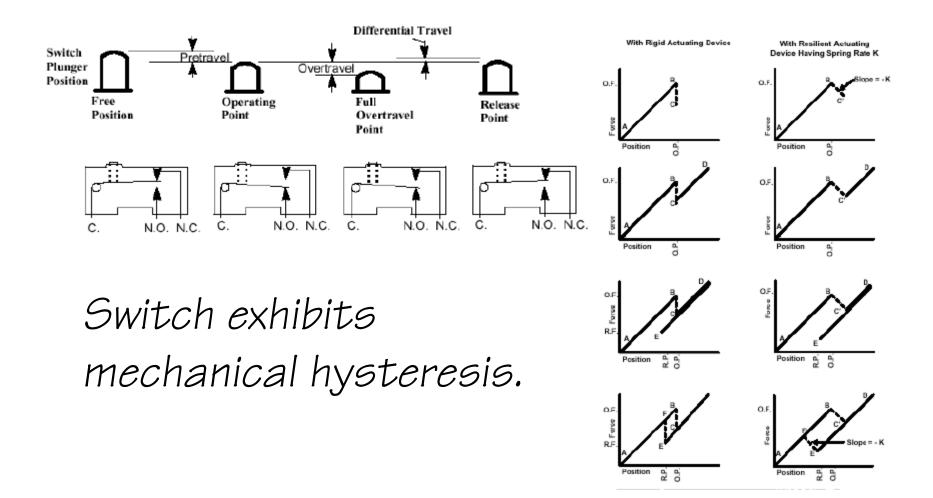
POSITION SENSING

- Mechanical
- Optical
- Magnetic
- Capacitive, Ultrasonic

MECHANICAL SENSING MICROSWITCH



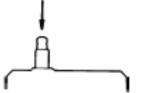
MICROSWITCH OPERATION



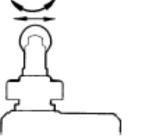
MICROSWITCH ACTUATORS



Pin plunger; in-line motion



Overtravel plunger; in-line applications requiring additional overtravel



Added overtravel in a panel mount roller plunger; Actuation by cams



Leaf; Low-force, slow moving cams or slides



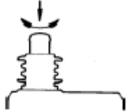
Roler lever; Very low force, fast moving cams



Roller leaf; Low-force, large movement actuation



Lever; Very low force, slow cams and slides



Added overtravel in a panel-mount plunger: Heavy-duty in-line applications or slow carns. Carn rise should not exceed 30°



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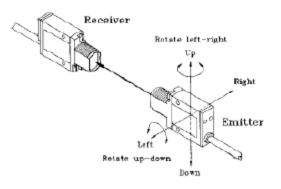
OPTICAL SENSING

- LED's and Photodiodes
- Transmissive/Reflective
- Modulated/Unmodulated
- Light-on/Dark-on
- Fiber optic

TRANSMISSIVE & REFLECTIVE SENSORS

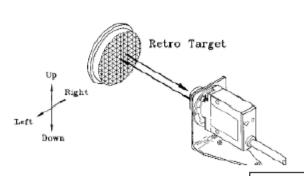
Opposed Mode Alignment

Opposed Mode Alignment: Move Emitter or Receiver Up-Down, Left-Right, and Rotate



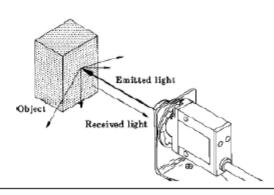
Retroreflective Mode Alignment

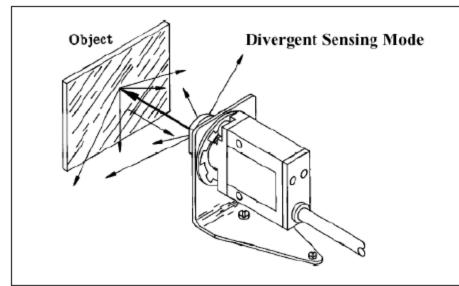
Retroreflective Mode Alignment: Move Target Up-Down, Left-Right

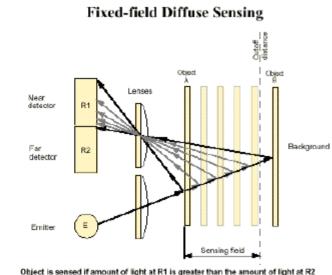


Proximity (Diffuse) Mode Alignment

Diffuse Mode Alignment: Rotate Up-Down, Left-Right

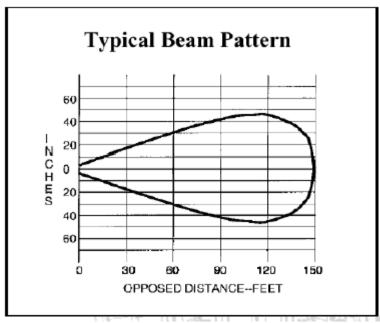


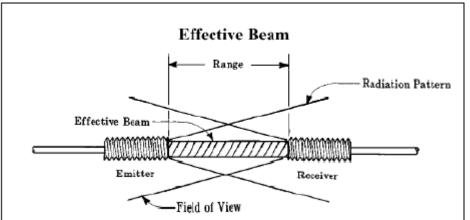




BEAM PATTERN AND REFLECTANCE

Mar II-198 WILLIAM III



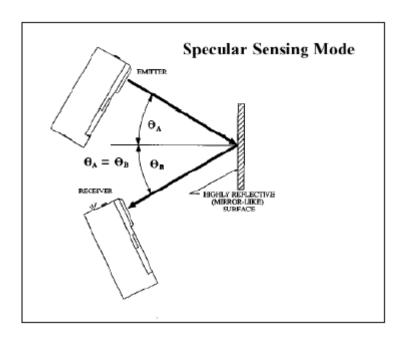


RELATIVE REFLECTIVITY TABLE

Material	Reflectivity (%)	Excess Gain Required
Kodak white test card	90%	1
White paper	80%	1.1
Masking tape	75%	1.2
Beer foam	70%	1.3
Clear Plastic*	40%	2.3
Rough wood pa (clean)	allet 20%	4.5
Black neoprene	4%	22.5
Natural alumi- num, unfinished	d* 140%	0.6
Stainless steel, microfinish	400%	0.2
Black anodized aluminum*	50%	1.8

*NOTE: For materials with shiny or glossy surfaces, the reflectivity figure represents the maximum light return, with the sensor beam exactly perpendicular to the material surface

SPECULAR REFLECTION



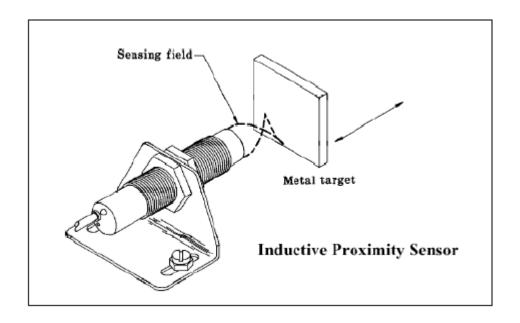
MODULATION

- "Chop" LED on and off at many kHz rate
- Bandpass filter after photodiode at the same frequency as chopping
- Threshold circuit after BPF generates on/off output

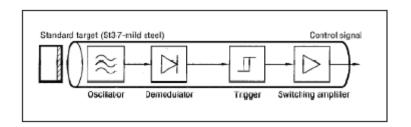
MAGNETIC POSITION SENSORS

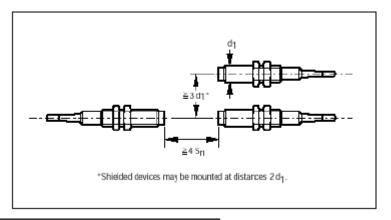
- Reed switches (sense permanent magnet)
- Inductive proximity sensors (eddy current)
- Hall Sensors (sense permanent magnet)

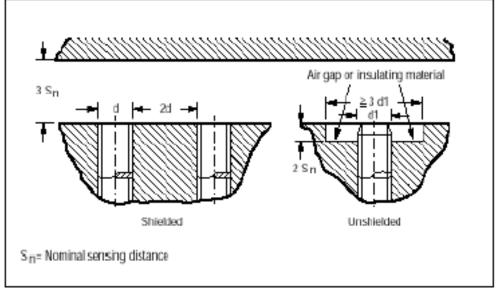
INDUCTIVE PROXIMITY SENSOR



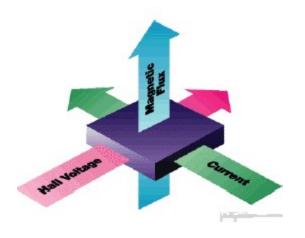
INDUCTIVE PROXIMITY SENSORS







HALL SENSORS



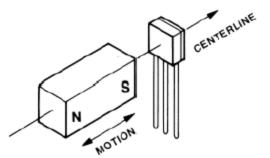


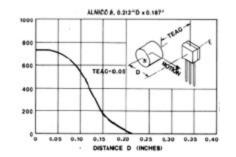
Hall effect:

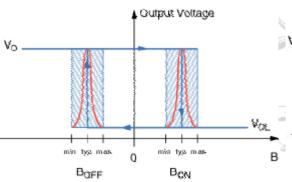
- constant voltage forces a constant current in semiconductor sheet
- magnetic field flux lines
 perpendicular to current cause
 proportional voltage across sheet.
- discovered by E.F.Hall in 1879
- Linear sensor needs voltage regulator and amplifier
- Switch also needs threshold circuit, with hysteresis

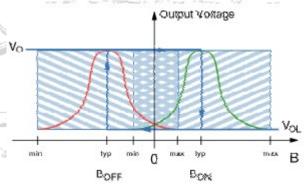
HALL SWITCH

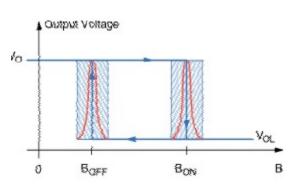
- Magnet motion
 - head-on
 - bypass or slide-by
- Total effective air gap (TEAG)
- Sensitivity, Hysteresis, & Temperature







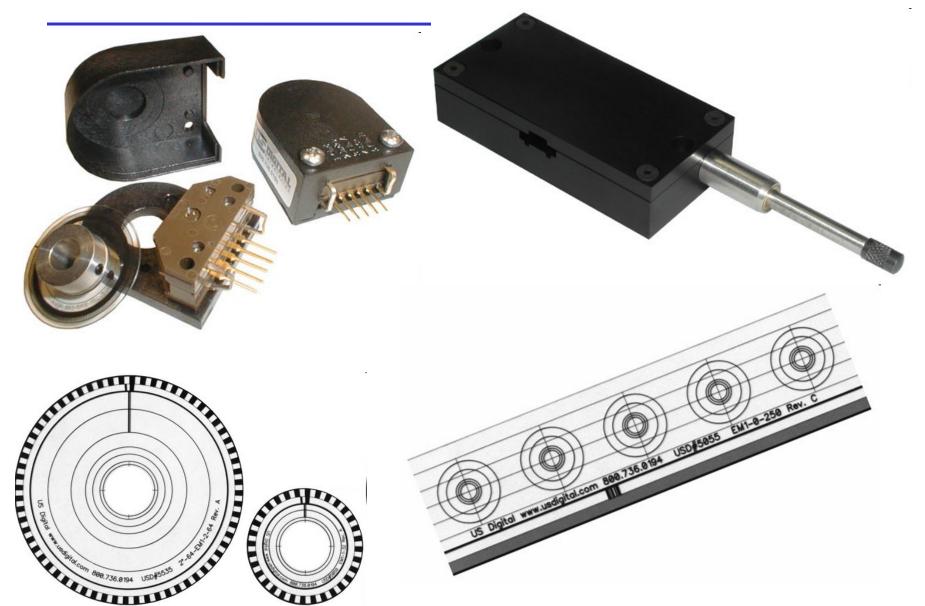




OTHER DISCRETE POSITION SENSORS

- capacitive
- ultrasonic
- variable reluctance (coil around magnet, senses moving ferrous material)

INCREMENTAL ENCODERS

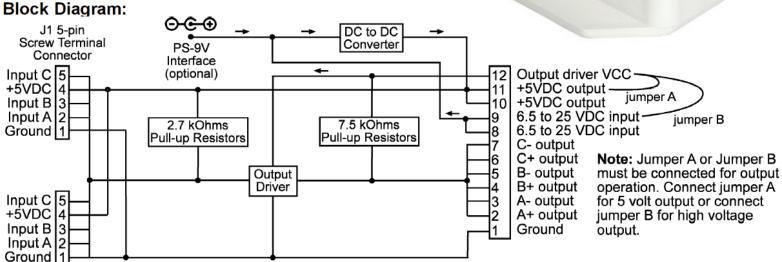


INCREMENTAL ENCODERS

- Encoders typically run on +5V, not +24V
- Outputs are typ. not 24V compatible either

J2 5-pin Finger-latching Connector

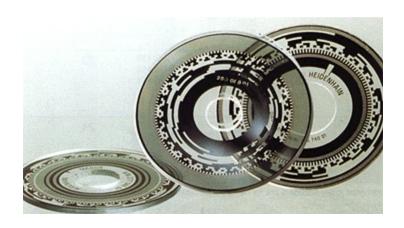


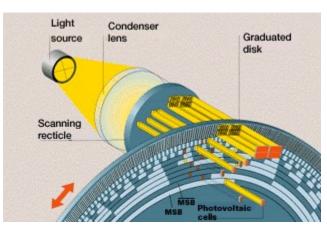


ABSOLUTE ENCODERS

- doubling resolution requires adding another photodiode/LED pair
- cost is much higher than incremental
- does not require seeking to establish reference location







POTENTIOMETER

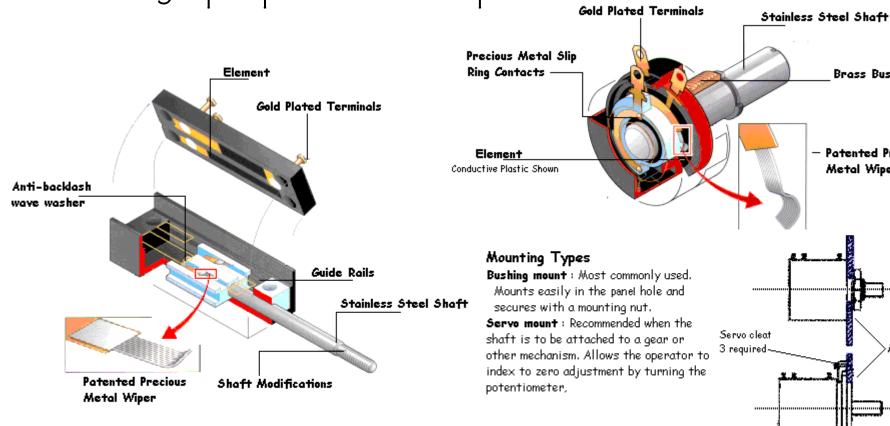
Brass Bushing

Potented Precious

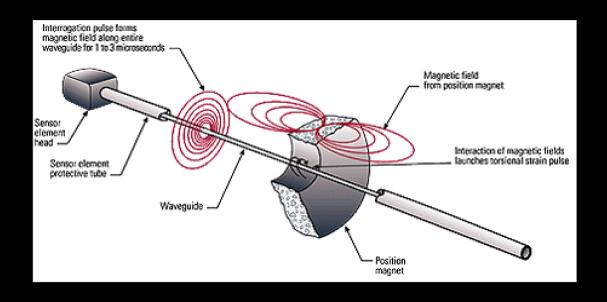
Mounting Panel

Metal Wiper

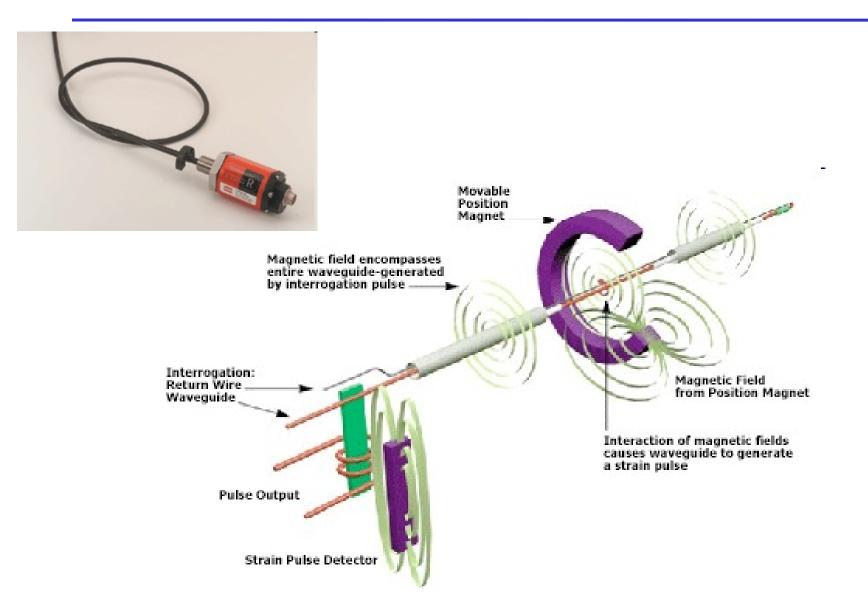
 A potentiometer (or pot) is a variable resistor wired to obtain a variable DC voltage proportional to position



MAGNETOSTRICTIVE POS. SENSOR

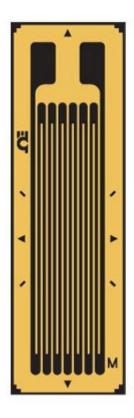


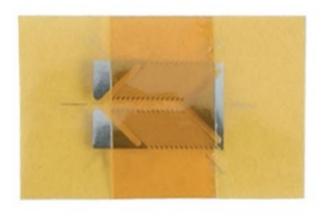
MAGNETOSTRICTIVE SENSOR



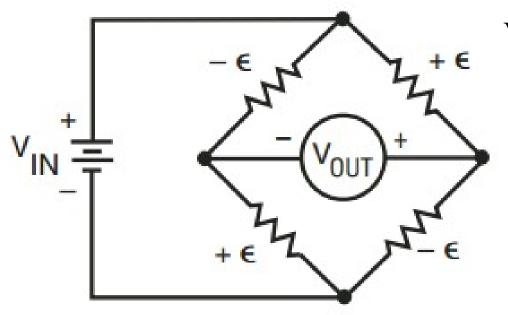
FORCE SENSING

- Strain gage
- Piezoelectric





STRAIN GAGES AND LOAD CELLS



Vr = Vout/Vin(strained) – Vout/Vin(unstrained)

GF = gage factor

$$\in = \frac{-V_r}{GF}$$

LOAD CELLS